



PATENT
Customer No. 22,852
Attorney Docket No. 04329.3253-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinya TAKYU et al.) Group Art Unit: 2822
Application No.: 10/787,207) Examiner: Kevin M. Picardat
Filed: February 27, 2004) Confirmation No.: 4683
For: SEMICONDUCTOR WAFER)
DIVIDING METHOD AND)
APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In a restriction requirement dated October 5, 2005, the Examiner required
restriction under 35 U.S.C. § 121 between among:

Group I, Claims 1-15, characterized by the Examiner as being drawn to the
method classified in class 438, subclass 460; or

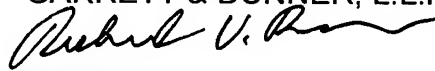
Group II, Claims 16-20, characterized by the Examiner as being drawn to the
apparatus, classified in class 451, subclass 1.

Applicants provisionally elect to prosecute Group I claims 1-15, without traverse.

Please grant any extensions of time required to enter this response and charge
any additional required fees to Deposit Account No. 06-0916.

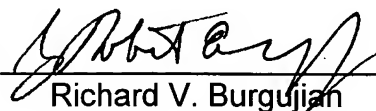
Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.



Dated: October 28, 2005

By:



#27,432

Richard V. Burgujian
Reg. No. 31,744

989739_1